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McDermott Will Emery

APR 2 5 2006

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Ramyar tarid

FACSIMILE

Date:

April 25, 2006

Time Sent:

To: Company: Facsimile No: Telephone No: 571-273-8300 Examiner Thao Le U.S. Patent and Trademark Office 202,756.8146 Ramyar M. Farid Direct Phone: From: Direct Fax: 202.756.8087 E-Mail: rfarid@mwe.com Direct Phone: 202-756-8661 Sent By: Matilda Mason No Original to Follow by Mail: Client/Matter/Tkpr: 60188-751 10 Number of Pages. Including Cover:

Re:

Application No.:

10/754,518

Attorney Docket No.:

60188-751

Message:

This Amendment is being filed in response to the Office Action dated January 25, 2006.

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U.S. practice conducted through McDermott Will & Emery LLP.

600 Thirteenth Street, N.W.

Washington, D.C. 20005-3096

Telephone: 202.756.8000

Docket No.: 060188-0751

PATENT

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

CENTRAL FAX CENTER

In re Application of

Customer Number: 20277

APR 2 5 2006

Yoshiharu HIDAKA, et al.

Confirmation Number: 8259

Application No.: 10/754,518

Group Art Unit: 2814

Filed: January 12, 2004

Examiner: Thao X, Le

For: SEMICONDUCTOR SUBSTRATE, METHOD FOR FABRICATING THE SAME, AND METHOD FOR

FABRICATING SEMICONDUCTOR DEVICE

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

Transmitted herewith is an Amendment in the above identified application.

No additional fee is required.

Applicant is entitled to small entity status under 37 CFR 1.27

Also attached:

The fee has been calculated as shown below:

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Marie Committee	NO. OF CLAIMS	HIGHEST PREVIOUSLY PAID FOR	EXTRA CLAIMS	RATE	FEE
Total Claims	- 10	20	0	\$50.00 =	\$0.00
Independent Claims	2	3	0	\$200.00 =	\$0.00
		Multiple dependent claims newly presented			\$0.00
Fee for extension of time					\$0.00
					\$0.00
		Total of Above Calculations			\$0.00

Please charge my Deposit Account No. 500417 in the amount of \$0.00.

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The Commissioner is hereby authorized to charge payment of any fees associated with this communication or credit any overpayment, to Deposit Account No. 500417, including any filing fees under 37 CFR 1.16 for presentation of extra claims and any patent application processing fees under 37 CFR 1.17.

Respectfully submitted,

McDERMOPTOWILL & EMERY LEP

Ramyar M. Farid

Registration No. 46,692

600 13th Street, N.W. Washington, DC 20005-3096 Phone: 202.756.8000 RMF:MWE

Facsimile: 202.756.8087 Date: April 25, 2006

Please recognize our Customer No. 20277 as our correspondence address.

Ø 003/010

APR 2 5 2006

Docket No.: 060188-0751 **PATENT**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of Customer Number: 20277

Yoshiharu HIDAKA, et al. Confirmation Number: 8259

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Examiner: Thao X. Le Filed: January 12, 2004

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METHOD FOR FABRICATING SEMICONDUCTOR DEVICE

AMENDMENT .

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated January 25, 2006, having a three-month shortened statutory period for response set to expire on April 25, 2006, reconsideration of the aboveidentified application is respectfully requested in view of the following amendment and remarks.